



Docket No.: 060188-0578

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 20277
Shinichi IMAI, et al.	:	Confirmation Number: 4939
Application No.: 10/619,191	:	Group Art Unit: 2125
Filed: July 15, 2003	:	Examiner: Maria N. Von Buhr
For: SYSTEM AND METHOD FOR MONITORING SEMICONDUCTOR PRODUCTION APPARATUS		

**AMENDMENT UNDER 37 CFR § 1.111**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are submitted under 37 CFR § 1.111 in response to the non-final Office Action mailed June 21, 2006.

**Amendments to the Claims** begin on page 2.

**Remarks** begin on page 6.